

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	54581	(chuck support holder stage) near20 (cool\$3 refrigerant "heat transfer")	US-PGPUB; USPAT	OR	OFF	2005/08/28 12:20
L2	6728	L1 same (wafer semiconductor substrate)	US-PGPUB; USPAT	OR	OFF	2005/08/28 12:20
L3	1327	L2 same plasma	US-PGPUB; USPAT	OR	OFF	2005/08/28 12:20
L4	146	L3 same (ring concentric\$4 annular)	US-PGPUB; USPAT	OR	OFF	2005/08/28 12:20

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	6240	118/666 156/345.52 156/345.53 156/345.27 118/724 118/725 219/390 219/391 219/496 219/411 219/165 392/416,418	USPAT	OR	OFF	2005/08/28 11:26
L2	1100	1 and concentric\$4	USPAT	OR	OFF	2005/08/28 11:27
L3	3017	1 and insulat\$4	USPAT	OR	OFF	2005/08/28 11:27
L4	670	2 and 3	USPAT	OR	OFF	2005/08/28 11:25
L5	398	2 and (vaccum evacuat\$4)	USPAT	OR	OFF	2005/08/28 12:05
L6	776	4 5	USPAT	OR	OFF	2005/08/28 11:29
L7	3	fink-stein.in. strang-eric.in.	USPAT	OR	OFF	2005/08/28 11:26
L8	6	fink-stein.in. strang-eric.in.	US-PGPUB; USPAT	OR	OFF	2005/08/28 11:49
L9	551	118/666 156/345.52 156/345.53 156/345.27 118/724 118/725 219/390 219/391 219/496 219/411 219/165 392/416,418	US-PGPUB	OR	OFF	2005/08/28 11:27
L10	129	9 and concentric\$4	US-PGPUB	OR	OFF	2005/08/28 11:50
L11	307	9 and insulat\$4	US-PGPUB	OR	OFF	2005/08/28 11:27
L12	129	9 and 10	US-PGPUB	OR	OFF	2005/08/28 11:28
L13	82	10 and 11	US-PGPUB	OR	OFF	2005/08/28 11:28
L15	0	10 11 12 13	USPAT	OR	OFF	2005/08/28 11:29
L16	354	10 11 12 13	US-PGPUB	OR	OFF	2005/08/28 11:29
L17	3103	((temperature thermal\$2) with zone\$1) with (chuck holder susceptor stage support)	USPAT	OR	OFF	2005/08/28 12:06
L18	889	17 and (insulat\$3)	USPAT	OR	OFF	2005/08/28 12:06
L19	146	17 same (insulat\$3)	USPAT	OR	OFF	2005/08/28 12:14
L20	660	((temperature thermal\$2) with zone\$1) with (chuck holder susceptor stage support)	US-PGPUB	OR	OFF	2005/08/28 12:06
L21	40	20 same (insulat\$3)	US-PGPUB	OR	OFF	2005/08/28 12:07